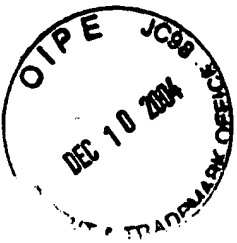


IFW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813  
Examiner: Thanhha S. Pham

In Re PATENT APPLICATION Of:

Applicant(s): Kazuhide ABE

Serial No.: 10/765,155

Filed: January 28, 2004

For: METHOD OF FORMING BURIED  
WIRING IN SEMICONDUCTOR DEVICE

Docket No.: MAE 306

)  
)  
)  
)  
) **RESPONSE TO**  
) **ELECTION OF SPECIES**  
) **REQUIREMENT**  
)  
)  
)

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Election of Species Requirement dated November 15, 2004, Applicant elects the embodiment of species **A**, as shown in Figures 2A through 2F, for examination. Claims 1 through 7 read on the elected species. The election is made without traverse. By making this election and selecting these claims for examination, however, Applicant does not restrict the scope of the listed claims to only the features of the exemplary embodiment shown in Figs. 2A through 2F. Rather, these claims may also read, for example, on other exemplary embodiments described in the specification, and should be afforded the broadest scope allowed by the relevant prior art.

Examination of the application on the merits is respectfully requested.

Respectfully submitted,

Robert H. Berdo, Jr. – Reg. No. 38,075  
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Telephone: 202-371-8976  
Facsimile: 202-408-0924

December 10, 2004  
Date

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